

1763



**PATENT**  
**MIC04 P-106**

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group : 1763  
Applicant : Imad Mahawili, PhD  
Serial No. : 09/488,309  
Filed : January 20, 2000  
For : REACTOR WITH REMOTE PLASMA SYSTEM AND  
METHOD OF PROCESSING A SEMICONDUCTOR SUBSTRATE

Commissioner for Patents  
Washington, D.C. 20231

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JUN 22 2001

Dear Sir:

**TC 1700**

CERTIFICATE OF MAIL

I certify that the attached return postcard, Second Supplemental Information Disclosure Statement, Form PTO-1449, and copies of references cited herein are being deposited with the United States Postal Service as first class mail in an envelope addressed to:

Commissioner for Patents  
Washington, D.C. 20231

on June 18, 2001.

Lynette M. S. Clark  
Lynette M. S. Clark  
Van Dyke, Gardner, Linn & Burkhardt, LLP  
P.O. Box 888695  
Grand Rapids, MI 49588-8695  
(616) 975-5500

CSC:lmsc  
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Dear Sir:

SECOND SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

In accordance with 37 CFR 1.51, 1.56, 1.97 and 1.98, Applicant submits herewith patents, publications or other information listed on attached Form PTO-1449 for consideration by the Examiner in connection with examination of the present application.

This Supplemental Information Disclosure Statement is being filed: (a) within three months of the filing date of the national application; (b) within three months of the date of entry of the national stage as set forth in 37 CFR § 1.491 in the corresponding international application; or (c) before the Applicant is aware of any mailing date of a first Office Action on the merits, whichever occurs last.

This Supplemental Information Disclosure Statement is not intended to constitute an admission that any patent, publication or other information referred to herein is "prior art" for this invention unless specifically designated as such.

Under 37 CFR 1.97(h), the filing of this Supplemental Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists.

Applicant : Imad Mahawili, Ph.D  
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An early and favorable action on the merits is respectfully requested.

Respectfully submitted,

IMAD MAHAWILI, PHD

By: Van Dyke, Gardner, Linn & Burkhardt, LLP

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TC 1700

June 18, 2001  
Date

*labeled*  
Catherine S. Collins  
Registration No. 37 599  
P.O. Box 888695  
Grand Rapids, Michigan 49588-8695  
(616) 975-5500

CSC:lmsc